



Docket No.: 060188-0031

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Kentaro SHIOMI , et al. : Confirmation Number: 6677
Application No.: 09/779,440 : Group Art Unit: 2132
Filed: February 09, 2001 : Examiner: Jung Kim
For: LSI DESIGN METHOD AND VERIFICATION METHOD

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 28, 2005, having a three-month shortened statutory period for response set to expire on February 28, 2006, and the petition for a two-month extension of time up to and including April 28, 2006 being filed concurrently herewith, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.